OIPE JC17 RECEIVED FEB 17 2004 PATENT & TRADEMARK OFFICE

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Dated: 2/13/04 Signature: Diane R. Lytle
(Diane R. Lytle)

Docket No.: 200309792-1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Adrian Kriz et al.

Application No.: 10/679,841 Confirmation No.: 3705

Filed: October 6, 2003 Art Unit: 2812

For: SEMI-CONDUCTOR WAFER FABRICATION Examiner: H. Jey Tsai

RESPONSE TO RESTRICTION REQUIREMENT

MS Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the restriction requirement set forth in the Office Action mailed January 13, 2004, Applicant hereby provisionally elects claims 1 – 10 and 18 – 23 (Group I).

Applicant believes no fee is due with this response. However, if a fee is due, please charge Deposit Account No. 08-2025 in the name of Hewlett-Packard Company.

Dated: February 13, 2004

Respectfully submitted,

By _____
Glenn E. Forbis
Registration No.: 40,610
RADER, FISHMAN & GRAUER PLLC
39533 Woodward Avenue
Suite 140
Bloomfield Hills, Michigan 48304
(248) 594-0636
Attorney for Applicant